

<b>Notice of References Cited</b>	Application/Control No. 10/698,767		Applicant(s)/Patent Under Reexamination CHENG ET AL.	
	Examiner Don Williams		Art Unit 2878	Page 1 of 1

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*	B	US-5,347,362	09-1994	Sugawara, Kenji	356/625
*	C	US-5,576,828	11-1996	Tomiyama et al.	356/625
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	M	US-			

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**NON-PATENT DOCUMENTS**

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